Applicant:	Masahiro IMADE, et al.	Docket No. 60188-612		
Title: Date Sent:	SEMICONDUCTOR DEVICE AND METHOD FOR FABRIC 6/24/2003		T ASSIGNED	
	ramittal Letter	☐ Electronic ☐ Cert. of Mailing ☐ Express Ma	nii No	
New Othe		☐ CIP ☐ Div. ☐ PCT ☐ CPA ☐ RC ☐ Letter submittingpages of drawing ☐ Req. for Approval of Drawing Amendments	8	
⊠ D	pages of Abstract pages of Formal Drawings mail Entity Large Entity eclaration/Power of Attorney	Req. for Oral Hearing Not. of Appeal Appeal Brief Rule 312 Amendment/Letter Req. for Acknowledgement of Cited Art Issue Fee	of Appeal Appeal Brief Reply Brief B12 Amendment/Letter for Acknowledgement of Cited Art	
	cordation of Assignment formation Disclosure Statement Form PTO 1449 copies of cited references	Publication Fee Req. for Certificate of Correction Maintenance Fee for	q. for Certificate of Correction intenance Fee foryears after grant	
☐ Re ☐ Re	retiminary Amendment esponse to Missing Parts Notice esp. to Notice to Correct App. Papers ertified Copy of Priority Doc. eim for Convention Priority	7 4 1905 G Terminal Disclaimer Petition to Commissioner		
	sim for Convention Priority sponse/Amendment to Office Action of	A THAT WAS A PARTIES		
Request formonth: Extension of Time				
Check for \$	☐ Charge Deposit Acct. 500417\$ 874.	00 Atty Init. MEF Tkpr. # 3328 Secy. or	Pt.: PR. Gordon	
CMS Descrip.	3-84	4-40 EA	N. V. CERIAL AUGUS	
THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.				